

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of :
Kenji SAWAMURA :
Serial No. NEW : **Attn: APPLICATION BRANCH**
Filed July 9, 2003 : Attorney Docket No. 2003_0942

SEMICONDUCTOR DEVICE HAVING A DUMMY
ACTIVE REGION FOR CONTROLLING HIGH
DENSITY PLASMA CHEMICAL VAPOR DEPOSITION
(Rule 1.53(b) Divisional
of Serial No. 10/058,131,
Filed January 29, 2002)

THE COMMISSIONER IS AUTHORIZED
TO CHARGE ANY DEFICIENCY IN THE
FEES FOR THIS PAPER TO DEPOSIT
ACCOUNT NO. 23-0975

CLAIM OF PRIORITY UNDER 35 USC 119

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Applicant in the above-entitled application hereby claim the date of priority under the International Convention of Japanese Patent Application No. 96413/1999, filed April 2, 1999, and Japanese Patent Application No. 83121/2000, filed March 24, 2000, as acknowledged in the Declaration of this application.

Certified copies of said Japanese Patent Applications are of record in parent application Serial No. 09/538,532, now U.S. Patent No. 6,495,855.

Respectfully submitted,

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